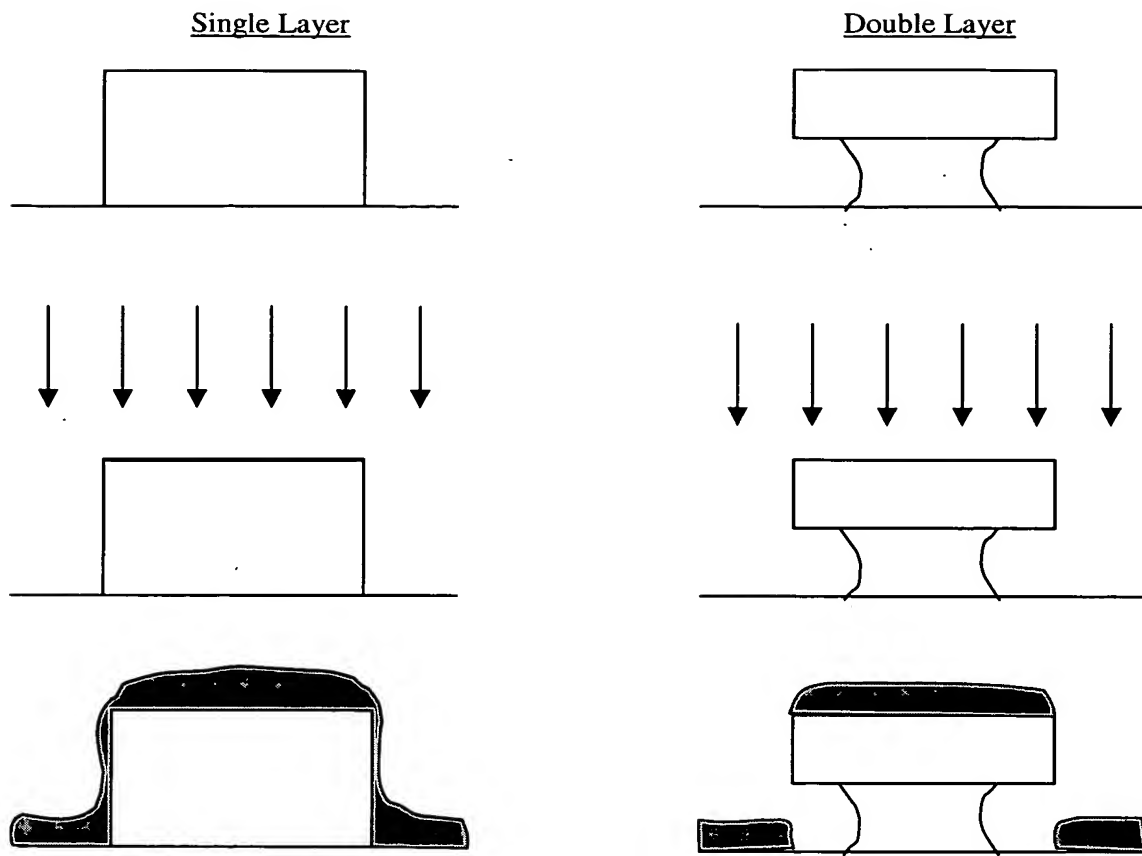


FIGURE 1



**FIGURE 2**

SEM of two layered resists after developing



**FIGURE 3**